

Federal Ministry of Economics and Technology







July 2013 Japanese-German Micro/Nano Business Forum Tokyo Big Sight, East Hall

The Forum, organized by IVAM Microtechnology Network with support of the Micromachine Center will take place during the Exhibition Micromachine/MEMS 2013 on July 4, 2013. The forum intends to deepen the international exchange about applications of micro and nano technologies and create business opportunities between the Japanese and the German Market and worldwide.

Session Chair

Dr. Lorenz Granrath

Representative Fraunhofer Representative Office Japan, Tokyo (J)

09:30	Start Registration	
10:00	Opening Remarks	Keiichi Aoyagi Micromachine Center Dr. Peter Scholz Ministry of Economic Affairs, Energy and Industry of the State of North Rhine-Westphalia Prof. Dr. Thomas Geßner Member of the Advisory Board of IVAM
10:10- 10:30	Open-access facility for MEMS R&D and production	Prof. Dr. Kentaro Totsu Micro System Integration Center, Tohoku University, Tokyo (J)
10:30- 11:00	3D-Integration for Smart Systems	Prof. Dr. Thomas Geßner Fraunhofer-Institut für Elektronische Nanosysteme ENAS, Chemnitz (D)
11:00- 11:20	Energy Harvesting Devices with Micro- machining Structures	Dr. Hiroyuki Yagyu Panasonic Corporation, Osaka [J]
11:20- 11:40	Research and Development of Micro Metal Injection Molding	Benjamin Hefler Taisei Kogyo Co., Ltd [J]
11:40- 12:00	High Quality Micro-machining with ps- lasers: The Process, Examples and Cost of Ownership	Dr. Bernhard Klimt Coherent Kaiserslautern GmbH, Kaiserslautern, [D]
12:00- 12:30	Break	
12:30- 12:50	Development of Polymer MEMS Process Technology and Its Application"	Prof. Dr. Susumu Sugiyama Ritsumeikan University, Kyoto [J]
12:50- 13:10	A new Optical Measurement Method for 3-D Vibration and Motion Measurement of MEMS / Micromachines	Morihito Hagura Polytec Japan, Kanagawa [J]
13:10- 13:25	Closing	